

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	34	"5754571"	US-PGPUB; USPAT; EPO; JPO	OR	ON	2006/05/22 09:26
L2	22	"4530600"	US-PGPUB; USPAT; EPO; JPO	OR	ON	2006/05/22 09:31
L3	17484	semiconductor with (Scan\$2 scanning)	US-PGPUB; USPAT; EPO; JPO	OR	ON	2006/05/22 09:43
L4	502	(amorphous with semiconductor) with (Scan\$2 scanning)	US-PGPUB; USPAT; EPO; JPO	OR	ON	2006/05/22 09:42
L5	7322	semiconductor with (Scan\$2 scanning) with laser	US-PGPUB; USPAT; EPO; JPO	OR	ON	2006/05/22 09:43
L6	757	semiconductor with (Scan\$2 scanning) with laser with speed\$3	US-PGPUB; USPAT; EPO; JPO	OR	ON	2006/05/22 09:43
L7	472	semiconductor with (Scan\$2 scanning) with laser with speed\$3 with beam	US-PGPUB; USPAT; EPO; JPO	OR	ON	2006/05/22 09:43
L8	97	semiconductor with (Scan\$2 scanning) with laser with speed\$3 with beam with surface	US-PGPUB; USPAT; EPO; JPO	OR	ON	2006/05/22 09:46
L9	153	(semiconductor and (Scan\$2 scanning) and laser and speed\$3 and beam and surface).clm.	US-PGPUB; USPAT; EPO; JPO	OR	ON	2006/05/22 09:56
L11	70	(semiconductor and (Scan\$2 scanning) and laser and speed\$3 and beam and surface and spot). clm.	US-PGPUB; USPAT; EPO; JPO	OR	ON	2006/05/22 09:56
L12	258	(semiconductor and (Scan\$2 scanning) and laser and speed\$3 and beam and surfaceand spot and amorphous).clm.	US-PGPUB; USPAT; EPO; JPO	OR	ON	2006/05/22 09:59
L13	3	(semiconductor and (Scan\$2 scanning) and laser and speed\$3 and beam and surface and spot and amorphous).clm.	US-PGPUB; USPAT; EPO; JPO	OR	ON	2006/05/22 09:59
L14	3	(semiconductor and (Scan\$2 scanning) and laser and speed\$3 and beam and surface and spot and amorphous).clm.	US-PGPUB; USPAT; EPO; JPO	OR	ON	2006/05/22 09:59

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L14	3	(semiconductor and (Scan\$2 scanning) and laser and speed\$3 and beam and surface and spot and amorphous).clm.	US-PGPUB; USPAT; EPO; JPO	OR	ON	2006/05/22 09:59